

02-18-2009



103548607

To the Director of the U.S. Patent and Trademark Office: Please record the attached documents or the new address(es) below.

**1. Name of conveying party(ies)**

CALIFORNIA INSTITUTE OF TECHNOLOGY  
FA9550-04-1-0434

Additional name(s) of conveying party(ies) attached?  Yes  No

**3. Nature of conveyance/Execution Date(s):**

Execution Date(s) 9 JANUARY 2009

- Assignment  Merger
- Security Agreement  Change of Name
- Joint Research Agreement
- Government Interest Assignment
- Executive Order 9424, Confirmatory License
- Other \_\_\_\_\_

**2. Name and address of receiving party(ies)**

Name: UNITED STATES AIR FORCE

Internal Address: AFOSR/PK

Street Address: 875 N. RANDOLPH STREET

SUITE 325, RM 3112

City: ARLINGTON

State: VA

Country: USA Zip: 22203

Additional name(s) & address(es) attached?  Yes  No

**4. Application or patent number(s):**

This document is being filed together with a new application.

A. Patent Application No.(s)

7,348,600

B. Patent No.(s)

FEB 17 2009

Additional numbers attached?  Yes  No

**5. Name and address to whom correspondence concerning document should be mailed:**

Name: UNITED STATES AIR FORCE

Internal Address: AFOSR/PK

Street Address: 875 N. RANDOLPH STREET

City: ARLINGTON

State: VA Zip: 22203

Phone Number: 703-696-7295

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**6. Total number of applications and patents involved:** \_\_\_\_\_

**7. Total fee (37 CFR 1.21(h) & 3.41) \$ 0**

- Authorized to be charged by credit card
- Authorized to be charged to deposit account
- Enclosed
- None required (government interest not affecting title)

**8. Payment Information**

a. Credit Card Last 4 Numbers \_\_\_\_\_  
Expiration Date \_\_\_\_\_

b. Deposit Account Number \_\_\_\_\_

Authorized User Name \_\_\_\_\_

**9. Signature:**

Signature

9 February 09  
Date

Name of Person Signing

Total number of pages including cover sheet, attachments, and documents:

2009

## License to the United States Government

Invention Title: Nitride Semiconductor Device, and Its Fabrication Process

Inventors: Axel Scherer; Yokio Narukawa; Isamu Niki; Koichi Okamoto; Yoichi Kawakami; Mitsuru Funato; Shigeo Fujita

U.S. Patent No.: 7,348,600

US Filing/Issue Date: 3/25/2008

Grant/Contract Identification No: FA9550-04-1-0434

Foreign Applications filed/intended in (countries):

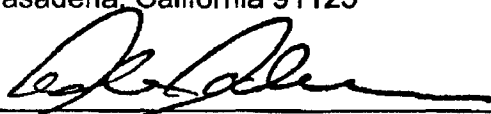
The invention identified above is a Subject Invention under 35 U.S.C. 200, et seq., and the Standard Patent Rights clause at 37 CFR 401.14 or FAR 52.227-11, which are included among the terms of the above-identified grant/contract award from the Air Force (AFOSR). This document is confirmatory of:

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The Government is here by granted an irrevocable power to inspect and make copies of the above-identified patent application.

California Institute of Technology  
1200 E. California Boulevard  
Pasadena, California 91125

Dated: January 9, 2009

  
Adam Cochran  
The Intellectual Property Counsel

CIT File No: 5118